

FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional) 81864.0053	Application Number Not Assigned 1056427
	Applicant Kenya TAKAGAWA, et al.	
	Filing Date February 28, 2005	Group Art Unit Not Assigned

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/J.H./	5,518,642	05/21/1996				

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
/J.H./	06-310321	11/04/1994	JAPAN			Abstract	
/J.H./	08-045725	02/16/1996	JAPAN			Abstract	
/J.H./	61-252610	11/10/1986	JAPAN			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER /John Hevey/	DATE CONSIDERED 10/12/2007
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	

FORM PTO-1449

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81864.0053Application Number
10/526,427INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

Applicant

Kenya TAKAGAWA, et al.

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						YES	NO
/J.H./	2000-159523	06/13/00	JAPAN			Abstract	
/J.H./	56-005331	01/20/81	JAPAN			Abstract	
/J.H./	11-003813	01/06/99	JAPAN			Abstract	

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